



Attorney's Docket No.: 42P17282

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Patent Application of:

Hok-Kim Choi, et al.

Examiner: Daniel S. Larkin

Application No: 10/750,199

Art Unit: 2856

Filing Date: December 30, 2003

For: A METHOD TO ASSAY  
SACRIFICIAL LIGHT ABOsorbing  
MATERIALS AND SPIN ON GLASS  
MATERIALS FOR CHEMICAL  
ORIGIN OF DEFECTIVITY

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION/AMENDMENT**

Sir:

In response to the Office Action mailed November 30, 2005, Applicants respectfully request the Examiner to enter the following amendments and consider the following remarks:

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on January 31, 2006

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Date of Deposit

Trina Chau

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Name of Person Mailing Correspondence

  
Signature

January 31, 2006

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Date